METHOD FOR MANUFACTURING A FLAT PANEL DISPLAY USING LOCALIZED WET ETCHING

Abstract of the Disclosure

A method is provided for locally etching certain structures formed in outer peripheral areas of field emission devices. The structures include alignment marks and bond pads, which require removal of materials deposited on the structures during manufacture.

 $vallabh_rajesh \ J: Vallabh_Rajesh \ Legal \ docs \sim fl \ 100718.419 \ apl. wpf_wpd. doc$